



Attorney's Docket No.: 10559-918001 / P18214

JFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Alexander Tregub et al. Art Unit : 1762
Serial No.: 10/799,435 Examiner : Unknown
Filed : March 12, 2004
Title : PROCESS TO OPTIMIZE PROPERTIES OF POLYMER PELLICLES AND
RESIST FOR LITHOGRAPHY APPLICATIONS

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

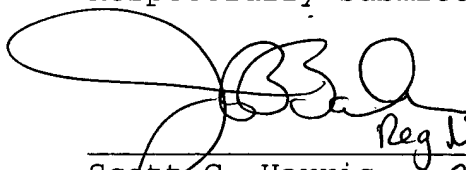
Applicant submits the references listed on the attached
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This statement is being filed within three months of the
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Respectfully submitted,

Date: _____

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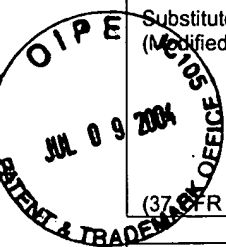
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Substitute Form PTO-1449 (Modified)	U.S. Department of Commerce Patent and Trademark Office	Attorney's Docket No. 10559-918001	Application No. 10/799,435
Information Disclosure Statement by Applicant (Use several sheets if necessary) (37 CFR §1.98(b))		Applicant Alexander Tregub et al.	
		Filing Date March 12, 2004	Group Art Unit 1762

U.S. Patent Documents

Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

Foreign Patent Documents or Published Foreign Patent Applications

Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Subclass	Translation	
							Yes	No
	AL							
	AM							
	AN							
	AO							
	AP							

Other Documents (include Author, Title, Date, and Place of Publication)

Examiner Initial	Desig. ID	Document
	AQ	K.R. Walton, "The Lubrication of Gold Surfaces by Plasma-Deposited Thin Films of Fluorocarbon Polymer," IEE Transactions on Components, Hybrids, and Manufacturing Technology, v. CHMT-no. 2, 1980
	AR	Karis et al., "Characterization of a Solid Fluorocarbon Film on Magnetic Recording Media," J.Vac. Technol., A 15(4), 1997
	AS	Karis et al., "Tribology of a Solid Fluorocarbon Film on Magnetic Recording Media," IEEE Transaction on Magnetism, V. 34, No. 4, 1998
	AT	Theirich et al., "A Novel Technique for High rate Plasma Polymerization with Radio Frequency Plasmas," Surface and Coating Technology 86-87, 1996

Examiner Signature	Date Considered
EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	

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Other Documents (include Author, Title, Date, and Place of Publication)		
Examiner Initial	Desig. ID	Document
	AU	P. Singer, "Atomic Layer Deposition Targets Thin Films," Semiconductor International, September 1, 1999
	AV	Mark LaPedus "Nikon Evaluating 157-nm Lithography Options," Semiconductor Business News, 5/23/2003
	AW	Resrick & Bucks, "Teflon AF Amorphous Fluoropolymers." Chapter 22 in Modern Fluoropolymers, Edited by J. Schews, Jon Wiley & Sons, 1997
	AX	Sugiyama, "Perfluoropolymers Obtained by Cyclopolymerization and Their Applications," Chapter 28 in Modern Fluoropolymers, Edited by J. Schews, Jon Wiley & Sons, 1997
	AY	Seki et al., Phys. Scripta 41:167(1990))

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